

<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				ATTY DOCKET NO. 129/015		SERIAL NO. <u>10/633,130</u> <del>To be assigned</del>	
				Fischione et al.			
				FILING August 1, 2003		GROUP 1753	

  

U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
SHV	3,958,124	5/18/76	Koch et al.	250	440.11		
SHV	5,633,502	5/27/97	Fischione	250	441.11		
SHV	6,190,062	2/20/01	Subramanian et al.	396	578		

  

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

  

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
SHV			Model 682, Precision Etching Coating System (PECS), Gatan Inc., 2001
SHV			Ion Beam Sputter Deposition and Etching System IBS/e, downloaded from the Internet at <a href="http://www.southbaytech.com/cgi-bin/homepage/products/view_product.cfm">http://www.southbaytech.com/cgi-bin/homepage/products/view_product.cfm</a> .

  

EXAMINER	DATE CONSIDERED <u>August 4, 2005</u>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

